

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ΔΡΡΙΙΟΔΝΊ	T: TSUTOMU YAMADA ET AL.)	
AI I LICAIV	1. 15010M0 17MMD/1 D1 712.) Group Art Unit:	2812
SERIAL NO	0.: 09/966,692)	
) Before the Examir	ier:
FILED:	September 28, 2001) S. Mulpuri	
)	
FOR:	METHOD OF ATTACHING LAYER)	
	MATERIAL AND FORMING LAYER)	
	IN PREDETERMINED PATTERN ON)	E
	SUBSTRATE USING MASK)	ECHNOLOGY
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			0
			92

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 24, 2003, Applicants request reconsideration in view of the following amendment and remarks for entry in the aboveidentified application.

> I hereby certify that this correspondence was mailed via First Class Mail and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

> > December 19, 2003 (Date of Deposit)

Agatha Skierkowski

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